



Docket No.: 060188-0648

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Makoto FUJIWARA, et al. : Confirmation Number: 4108
Application No.: 10/654,084 : Group Art Unit: 2135
Filed: September 04, 2003 : Examiner: VU, KIM Y

For: SEMICONDUCTOR DEVICE INCLUDING ENCRYPTION SECTION,
SEMICONDUCTOR DEVICE INCLUDING EXTERNAL INTERFACE, AND CONTENT
REPRODUCTION METHOD

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference was first cited in a corresponding foreign application office action and its relevance discussed therein. A copy of the foreign office action, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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SHEET 1 OF 1

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)			ATTY. DOCKET NO. 060188-0648	SERIAL NO. 10/654,084		
			APPLICANT Makoto FUJIWARA, et al.			
			FILING DATE September 04, 2003	GROUP 2135		
U.S. PATENT DOCUMENTS						
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ₂ (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
	US	6,618,807 B1	09/09/2003	Wang et al.	Corresponds with TW 420796	
	US					
	US					
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	US					
	US					
FOREIGN PATENT DOCUMENTS						
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number-Kind Codes (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation Yes No
		TW 420796	-	-	Corresponds with USP 6,618,807 B1	<input checked="" type="checkbox"/> <input type="checkbox"/>
		EP 1 441 340 A2	07/28/2004	KABUSHIKI KAISHA TOSHIBA MATSUSHITA ELECTRIC INDUSTRIAL CO., LTD.	Corresponds with TW 479191	<input checked="" type="checkbox"/> <input type="checkbox"/>
		TW 479191	-	-	Corresponds with EP 1 441 340 A2	<input checked="" type="checkbox"/> <input type="checkbox"/>
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)						
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				
EXAMINER			DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered.
Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.